

In re Application of:

Farnworth et al.

Serial No.: 10/666,930

Filed: September 19, 2003

For: METHOD FOR SUPPORTING WAFERS FOR DIE SINGULATION AND SUBSEQUENT HANDLING (as amended)

Confirmation No.: 6453

Examiner: S. Isaac

Group Art Unit: 2812

Attorney Docket No.: 2269-5529US

(02-0766.00/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

1/24/2006
Date Signature
Erika Gandre

Name (Type/Print)

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

The following remarks are filed in response to the Examiner's remarks in the Final Office Action mailed November 30, 2005, the three-month shortened statutory period for response to which expires on February 28, 2006. This response is submitted on or before two months from the mailing date of the Final Office Action.

Remarks begin on page 2 of this paper.